IAPORAZIOPETATTO 27 JAN 2008

Atty. Dkt. No. 039262-0147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Tadahiro OHMI, et al.

Title:

SILICON CARBIDE PRODUCT, METHOD FOR PRODUCING THE

SAME, AND METHOD FOR CLEANING SILICON CARBIDE

PRODUCT

Appl. No.:

Unassgined

Filing Date:

January 27, 2006

Examiner:

Unassigned

Art Unit:

Unassigned

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.56

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56. Copies of the documents are not being provided since copies should have been provided directly by WIPO under an exchange program between the PTO, the EPO and the JPO.

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application or that such document is considered material to patentability as defined in 37 CFR §1.56(b). Applicants do not waive any rights to take any action which would be appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* art reference against the claims of the present application.

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TIMING OF THE DISCLOSURE

The listed documents are being submitted in compliance with 37 CFR §1.97(b), within three (3) months of the filing date of the application.

RELEVANCE OF EACH DOCUMENT

Any document listed on the attached PTO/SB/08 was cited as being relevant during the prosecution of the corresponding International application. A copy of the International Search Report is attached setting forth the portion of each document considered relevant by the examiner. An English-language counterpart of the foreign-language documents has not been provided. The absence of a translation or an English-language counterpart document does not relieve the PTO from its duty to consider any submitted document (37 CFR §1.98 and MPEP§609).

Applicants respectfully request that each listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 CFR §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 19-0741.

Respectfully submitted,

Date: January 27, 2006

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MODIFIED PTO/SB/08 (08-00)

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	Substitute fo	or form 1449B	/PTO	Complete if Known				
	INFORMATI	ON DISCLO	SURE	Application Number	Unassigned			
	STATEMEN			Filing Date	January 27, 2006			
				First Named Inventor	Tadahiro OHMI			
	Date Submitte	ea: January 2	27, 2006	Group Art Unit	Unassigned			
	(use as many	sheets as ne	cessary)	Examiner Name	Unassigned			
Sheet	1	of	1	Attorney Docket Number	039262-0147			

Cite lo.1	U.S. Patent I	Kind Code ² (if	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		U.S	. PATENT APPLICATION DOCUM	MENTS	
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	Cite No.1	Cite Docume	Cite Document No.1 Serial Number Code ² (if	U.S. Patent Application Document Name of Patentee or Applicant of Cited Serial Number Code ² (if Cited Document	Cite No.1 U.S. Patent Application Document Name of Patentee or Applicant of Cited Document Serial Number Code ² (if Name of Patentee or Applicant of Cited Document MM-DD-YYYY

				F	OREIGN PATENT DOCUMEN			
Examiner Initials*	Cite No. ¹	Offic	Foreign Patent D	Occument Kind Code ⁵ (if known)	Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	A1	JP	11-008216	A	TOSHIBA CERAMICS CO.	01-12-1999		
	A2	JP	2003-86792	A	NATIONAL INSTITUTE OF ADVANCE INDUSTRIAL SCI.	03-20-2003		
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	Cite	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the	
Initials* N	No.1	item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
A	А3	De VASCONCELOS et al., "Potential of High-purity Polycrystalline Silicon Carbide for Thermistor Applications," Japanese Journal of Applied Physics, Part 1, September 15, 1998, Vol. 37:9A, pp. 5078-5079.	
A	A4	CHOME et al., "Applications of High Purity SiC Prepared by Chemical Vapor Deposition, In Amorphous and Crystalline Silicon Carbide II, Springer Proceedings in Physics, Vol. 43, 1989, pp. 198-206.	

Examiner Signature	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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¹ Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.